



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Gianoulakis, et al.

Serial No.: 10/006,022

Confirmation No.: 8411

Filed: December 6, 2001

For: Substrate Support
Apparatus To Facilitate
Particle Removal

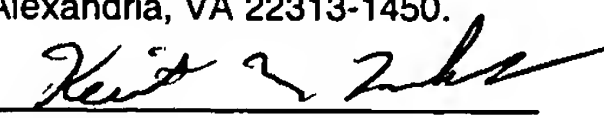
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Group Art Unit: 1763

Examiner: Ram N. Kackar

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE UNDER 37 CFR 1.10	
I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on January 30, 2004 with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV335477805US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
<u>1/30/04</u> Date	<u></u> Signature

PETITION FOR ONE-MONTH EXTENSION OF TIME

Applicant respectfully petitions the Commissioner under 37 CFR 1.136(a) to grant a one-month extension of time to and including January 30, 2004, in which to file the Request for Continued Examination (RCE) and Preliminary Amendment.

This form is filed in duplicate. The Commissioner is authorized to charge the fee of \$110.00 and any additional fees which may be required for this submission to Deposit Account No. 20-0782/5970.05/CPES/CORE/JB.

Respectfully submitted,



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